

U.S.S.N. 10,656,584

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hsu et al.

Group Art Unit: 1765

Serial No.: 10,656,584

Examiner: Tran, Binh X

Filed: 09/04/2003

In Response to Office Action

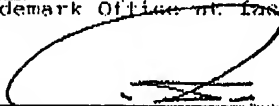
Dated: 04/27/2005

For: PLASMA TREATMENT METHOD TO REDUCE SILICON
EROSION OVER HDT SILICON REGIONS

Attorney Docket No.: 67,200-1117

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Randy W. Tung
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RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 04/27/2005,
please enter the following amendments and consider the following
remarks.